Search Notes	Application/Control No. 10626792	Applicant(s)/Patent Under Reexamination CHERITON, DAVID R.
	Examiner Rutkowski, Jeffrey	Art Unit 2473

SEARCHED

Class	Subclass	Date	Examiner
370	229, 349, 351, 389, 392, 401 (Updated Search)	3/17/2010	JMR
710	58 (updated search)	3/17/2010	JMR
365	189.05 (updated search)	3/17/2010	JMR
709	224 (updated search)	3/17/2010	JMR
726	24 (updated search)	3/17/2010	JMR
370	232,395.5 (bloom filter concepts)	3/17/2010	JMR
713	201 (bloom filter concepts)	3/17/2010	JMR
370	345 (epoch interval concepts)	3/18/2010	JMR

SEARCH NOTES

Search Notes	Date	Examiner
searched EAST for bloom filter concepts	3/17/2010	JMR
searched EAST for epoch interval concepts	3/18/2010	JMR

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner